## In the Claims:

Please cancel Claims 1-23 and add new Claims 24-41, such that Claims 24-41 are as set forth below.

- 24. (New) A composition for chemical mechanical planarization comprising hydroxylamine in an amount sufficient for chemical etching and a material selected from a group consisting of hydroxylamine nitrate, hydroxylamine sulfate, an ammonium salt, and any combination thereof, the ammonium salt selected from a group consisting of a nitrate salt, a sulfate salt, a phosphate salt, a chloride salt, and any combination thereof.
- 25. (New) The composition of claim 24, wherein the amount of hydroxylamine is from approximately 0.3 to approximately 10 percent by weight.
- 26. (New) The composition of claim 24, wherein the material comprises hydroxylamine nitrate in an amount of from approximately 0.1 to approximately 3 percent by weight.
- 27. (New) The composition of claim 24, wherein the material comprises hydroxylamine sulfate in an amount of from approximately 0.001 to approximately 12 percent by weight.
- 28. (New) The composition of claim 24, wherein the amount of hydroxylamine is from approximately 0.3 to approximately 10 percent by weight, and the material comprises hydroxylamine nitrate in an amount of from approximately 0.1 to approximately 3 percent by weight and hydroxylamine sulfate in an amount of from approximately 0.001 to approximately 12 percent by weight.
- 29. (New) The composition of claim 24, wherein the material comprises an ammonium salt selected from a group consisting of a nitrate salt, a sulfate salt, a phosphate salt, a chloride salt, and any combination thereof.
- 30. (New) The composition of claim 24, further comprising a material selected from a group consisting of a free radical inhibitor, an insoluble complexing agent, a soluble complexing agent, and any combination thereof.

CHEM.001US0 -5 - Serial No.: 10/017,934

- 31. (New) The composition of claim 30, wherein the free radical inhibitor is selected from a group consisting of hydrazine, hydrazine derivatives, hydrazine salts, hydrazid, hydrazid derivatives, and any combination thereof, in an amount sufficient to inhibit the formation of free radicals in the composition.
- 32. (Original) The composition of claim 30, wherein the free radical inhibitor comprises 4-hydrazine benzoic acid.
- 33. (New) The composition of claim 30, wherein the insoluble complexing agent is selected from a group consisting of benzotriazole, 1,6-dioxaspirol [4,4] nonane 2,7-dione, dioximes, and any combination thereof.
- 34. (New) The composition of claim 30, wherein the insoluble complexing agent comprises 2,4-pentanedione dioxime.
- 35. (New) The composition of claim 30, wherein the soluble complexing agent is selected from a group consisting of citric acid, copper-complexing catechol derivatives, copper-complexing alpha organic acids, copper-complexing hydroxamic acids, copper-complexing amino acids, copper-complexing dicarboxylic acids, and any combination thereof.
  - 36. (New) The composition of claim 24, further comprising an abrasive.
- 37. (New) The composition of claim 36, wherein the abrasive is selected from a group consisting of silica, alumina, ceria, titania, zirconia, and any combination thereof.
- 38. (New) The composition of claim 36, wherein the abrasive comprises colloidal silica.
- 39. (New) The composition of claim 36, wherein the abrasive comprises milled alumina.
- 40. (New) The composition of any one of claims 24-29, wherein a pH of the composition is in a range of from approximately 2.0 to approximately 5.0.

CHEM.001US0 -6 - Serial No.: 10/017,934

I	41. (New) A composition for chemical mechanical planarization comprising	
	hydroxylamine in an amount sufficient for chemical etching; a material selected from a group	
	consisting of hydroxylamine nitrate, hydroxylamine sulfate, an ammonium salt, and any	
	combination thereof, the ammonium salt selected from a group consisting of a nitrate salt, a	
	sulfate salt, a phosphate salt, a chloride salt, and any combination thereof; and 4-hydrazine	
	benzoic acid.	
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CHEM.001US0 -7 - Serial No.: 10/017,934